

SHEAR BANDS IN FILMS OF COLLOIDAL DISPERSIONS

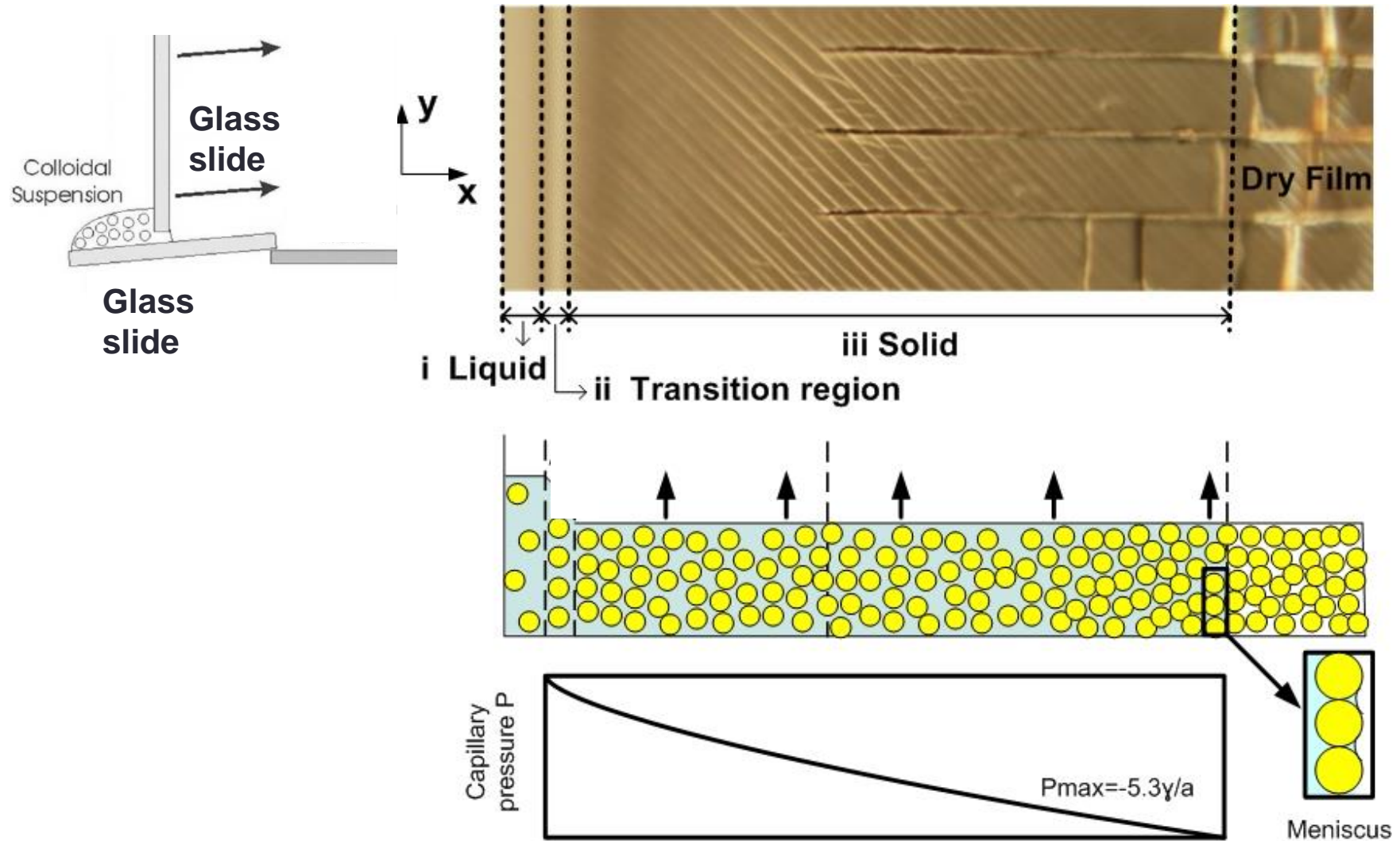
Bin Yang
James S. Sharp
Mike I. Smith



The University of
Nottingham

UNITED KINGDOM • CHINA • MALAYSIA

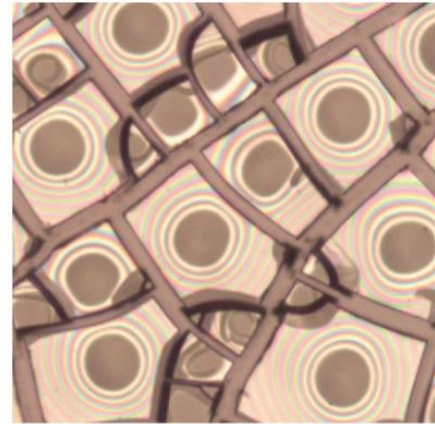
Planar drying of colloidal films



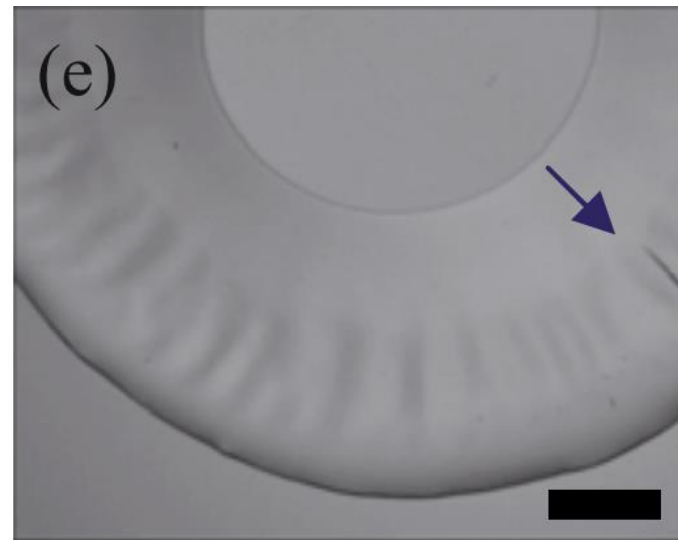
Strain release mechanisms in film formation



Crack formation



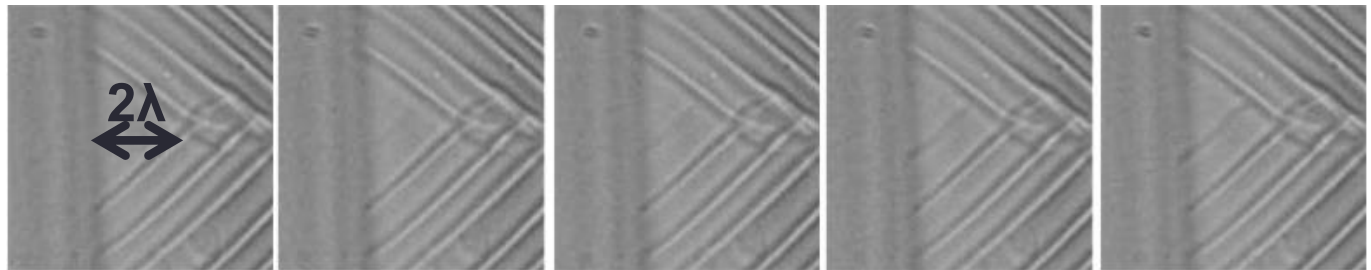
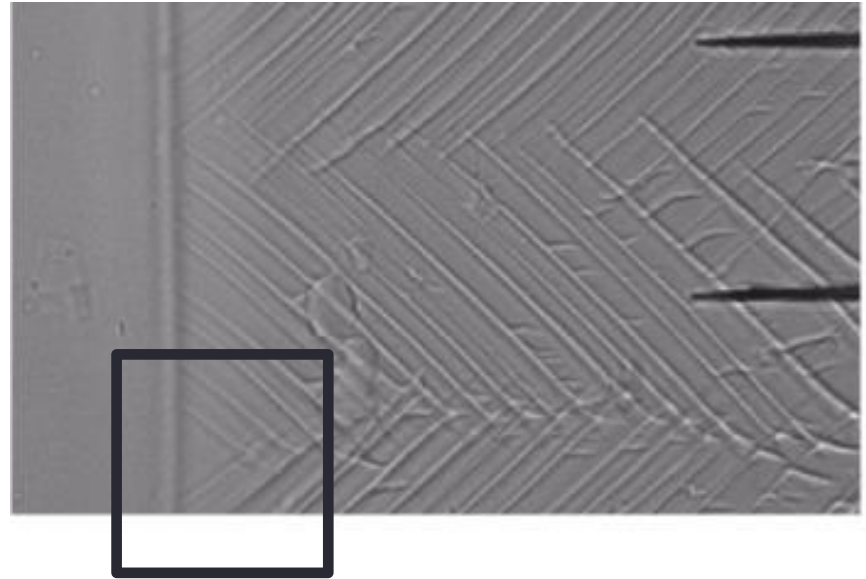
Film Delamination



Surface Wrinkling / Buckling

Diagonal Banding

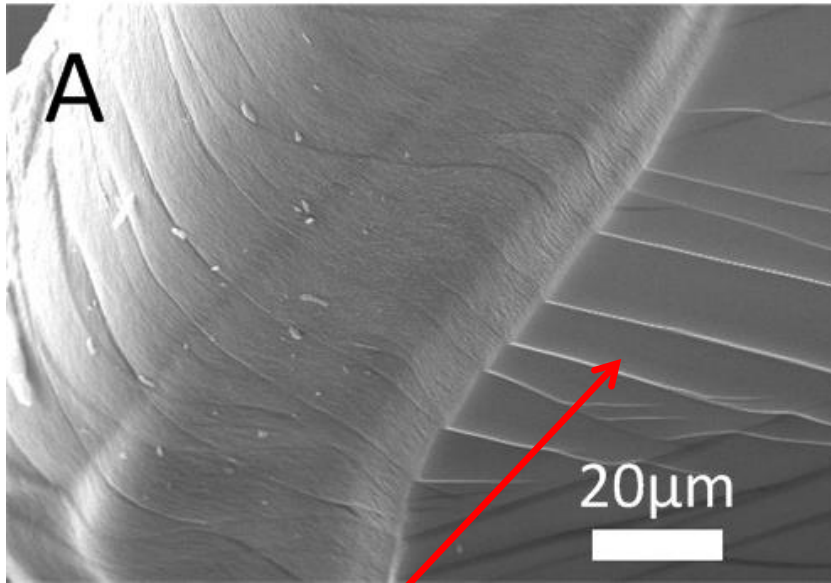
- ❑ Bands form behind transition region
- ❑ Bands form for 50 & 100nm particles but not 200nm and greater.



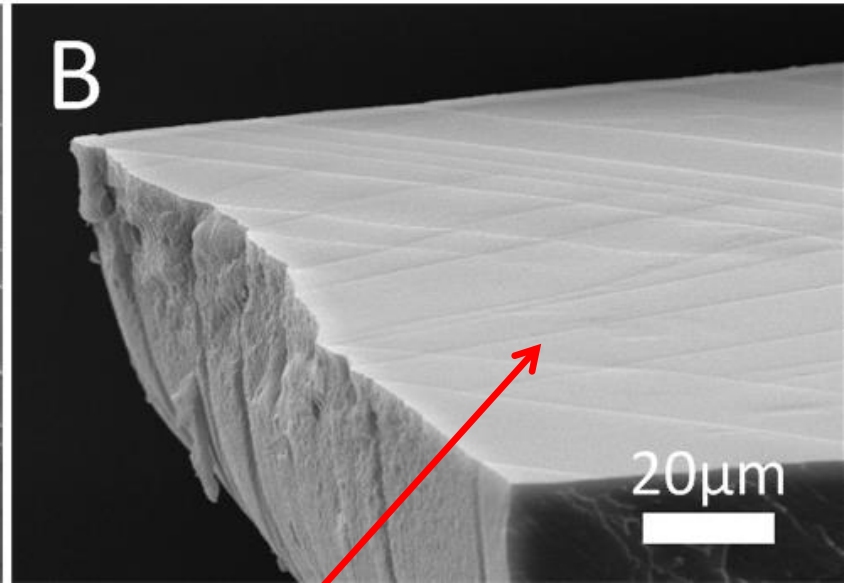
0s

0.17s

SEM of the band morphology

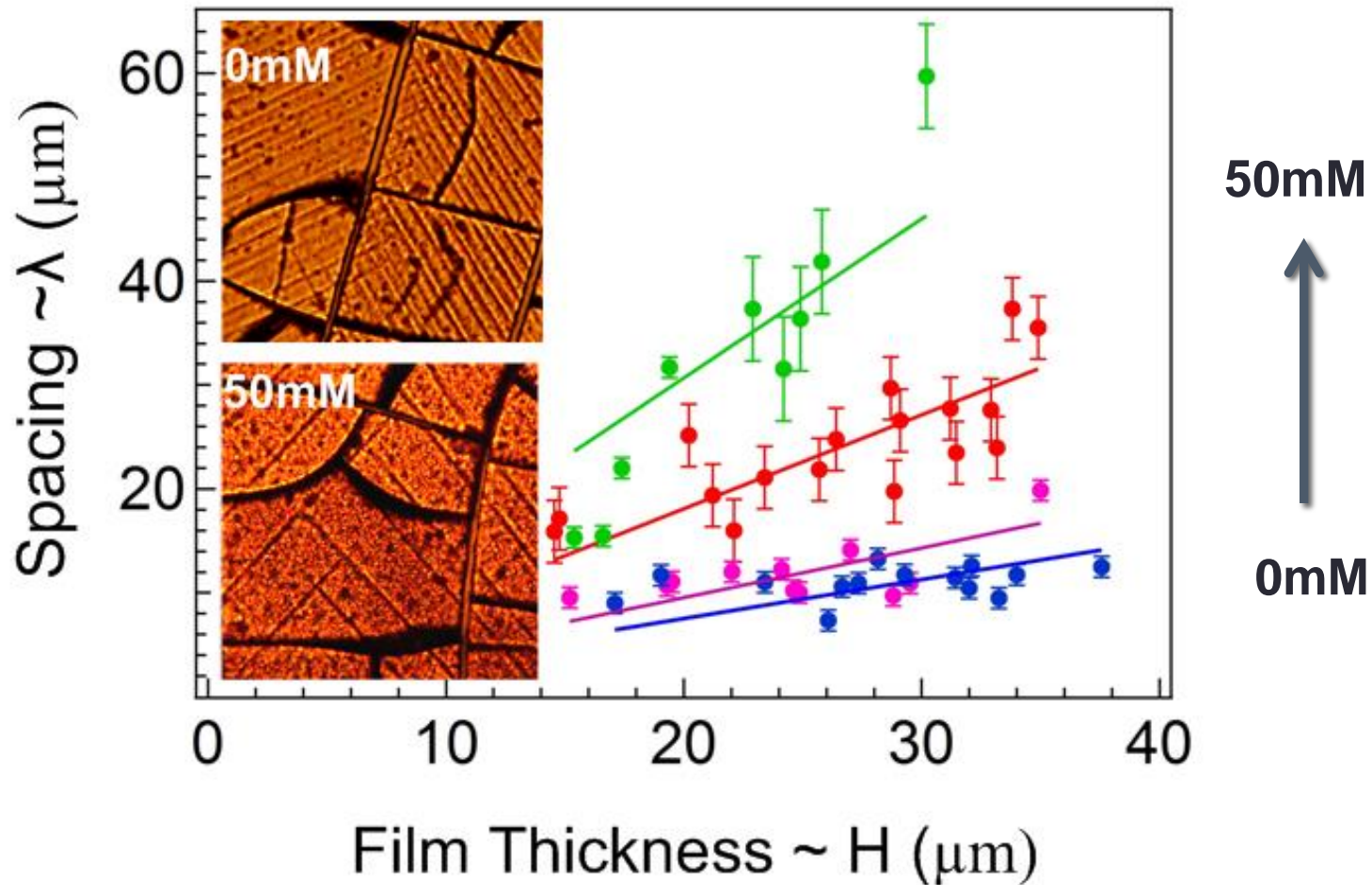


Bottom



Top

Band Spacing



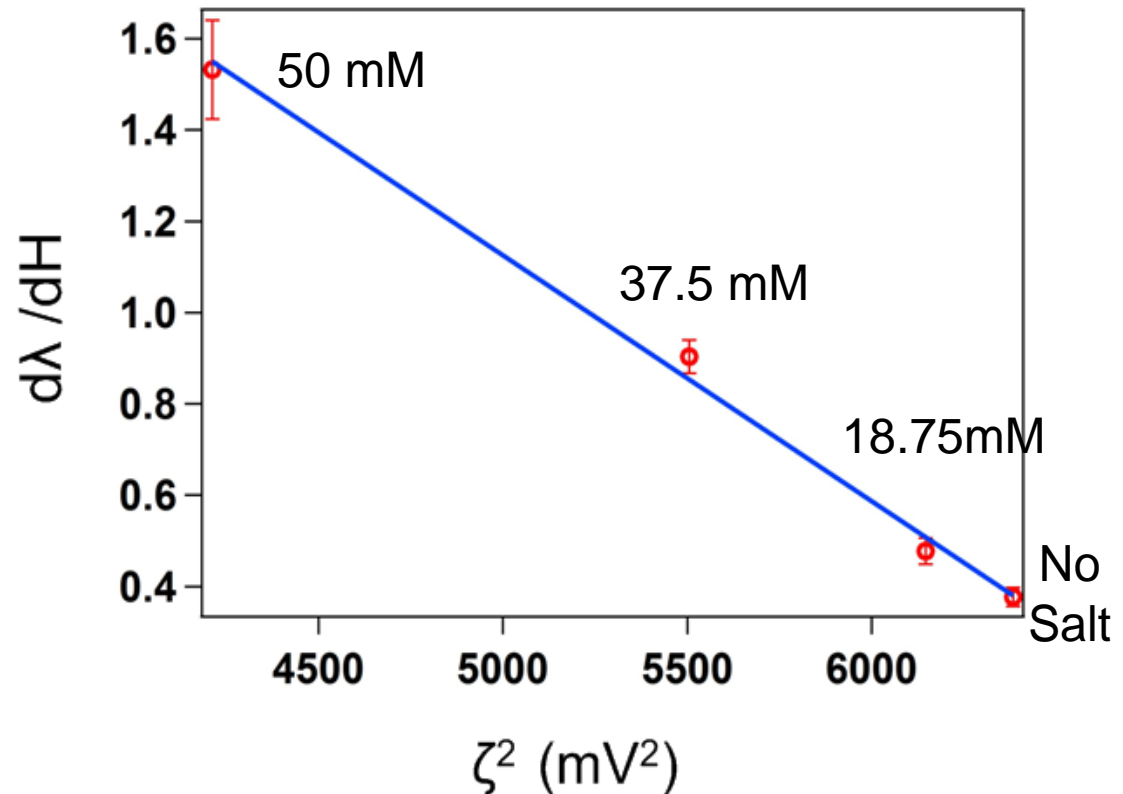
The role of yield stress

A shear band should occur when **the stress** applied to the film exceeds **the film yield stress**,

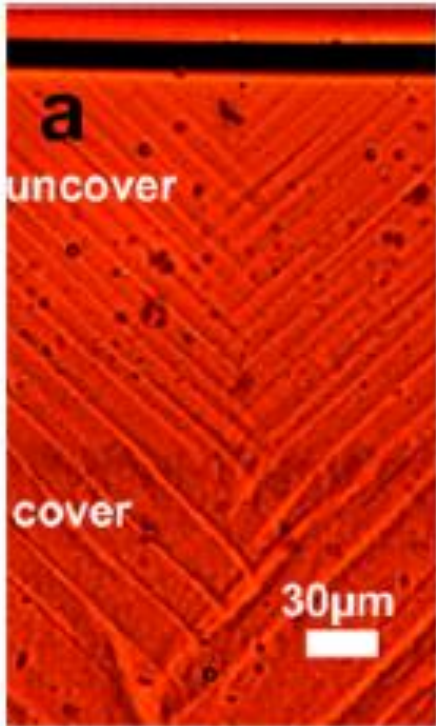
$$\sigma_y = A - B\zeta^2$$

$$d\lambda/dH = a - b\zeta^2$$

Spacing of bands depends on yield stress of film



Shear rate dependence – Lever rule



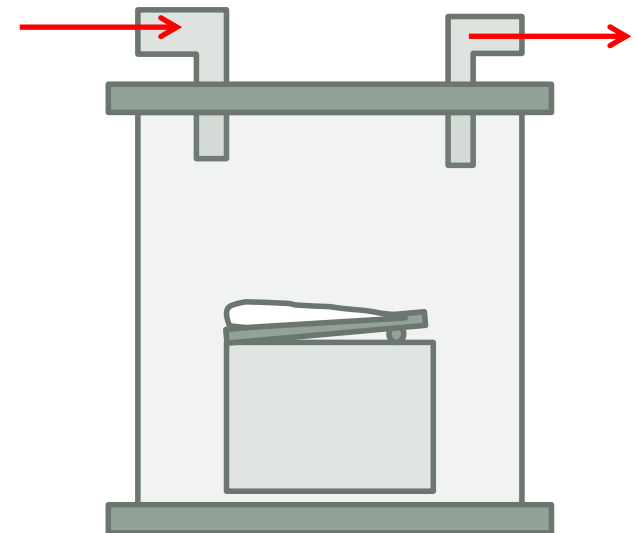
Shear banding in yield stress fluids is known to obey a Lever Rule → Rate dependence

$$\frac{\delta}{\lambda} \sim \frac{\dot{\gamma}}{\dot{\gamma}_c}$$

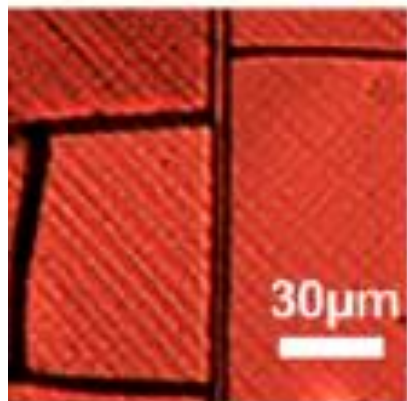
$\dot{\gamma}_c$ is a material dependent parameter

Controlling the evaporation rate alters the band spacing.

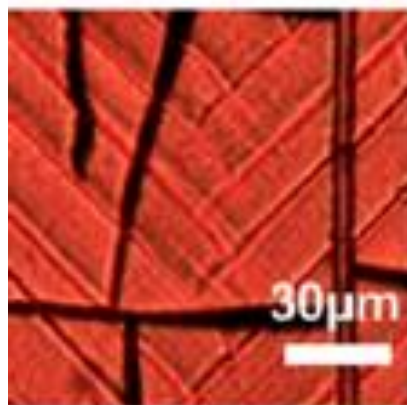
Controlled Humidity Air



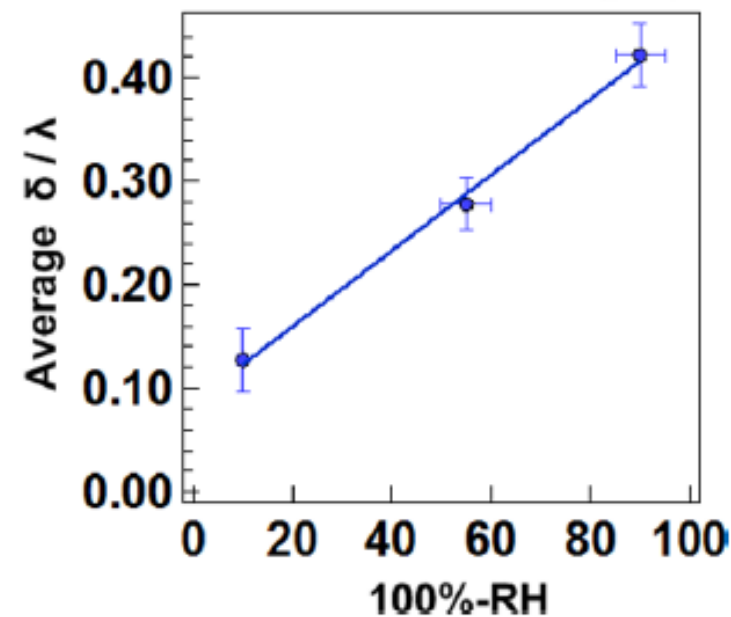
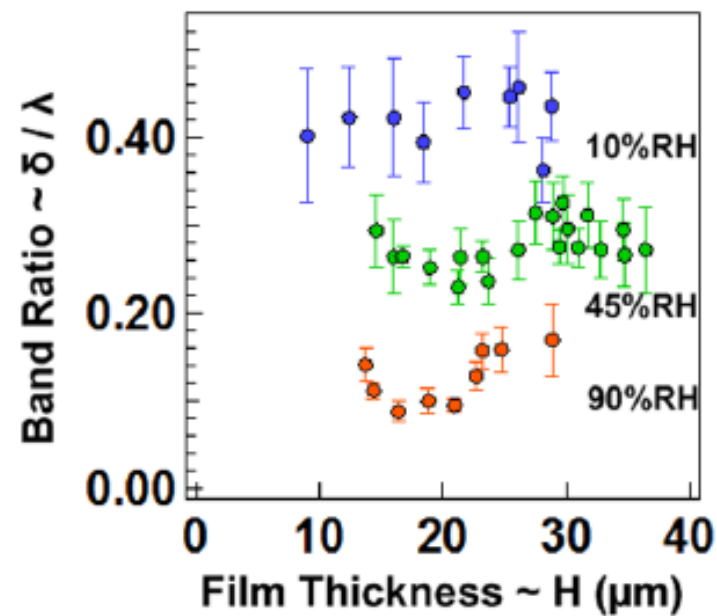
Fast



Slow

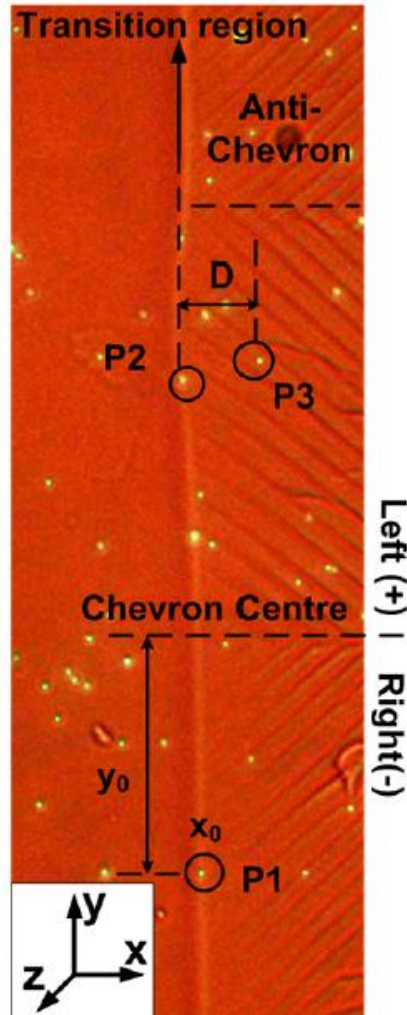


$$\frac{\delta}{\lambda} \sim \frac{\dot{E}_{dry}}{\dot{E}_c} \sim \frac{(100 - RH)}{\dot{E}_c}$$



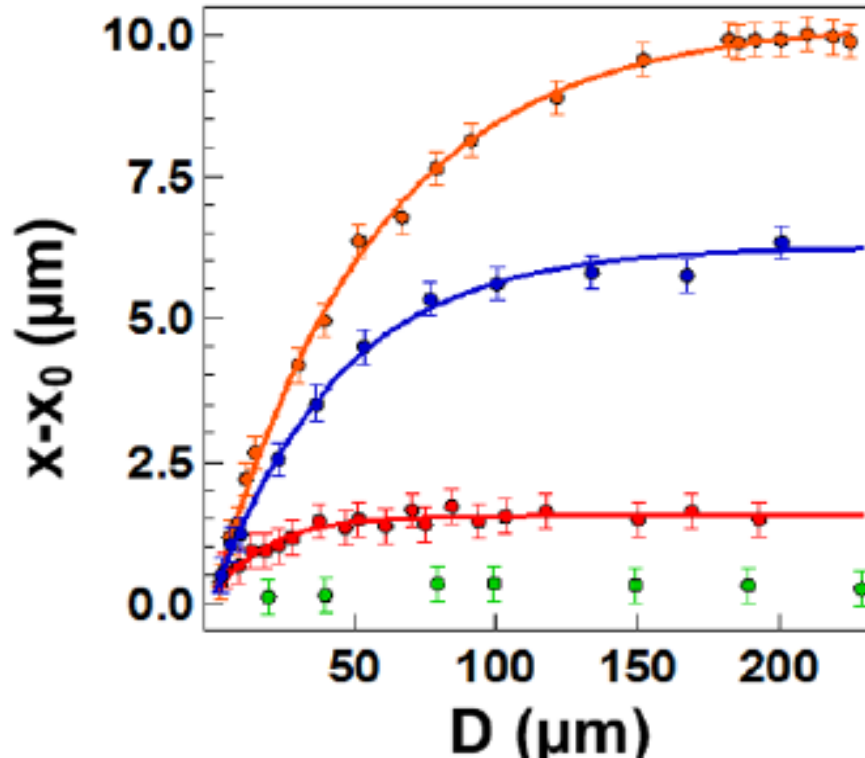
What causes shear band formation?

Measuring the film deformation



- ❑ Fluorescent tracer particles added to suspension
- ❑ Once particles become trapped at the transition region we track their x and y coordinates
- ❑ The small subsequent movements enable us to quantify film deformation

Compaction



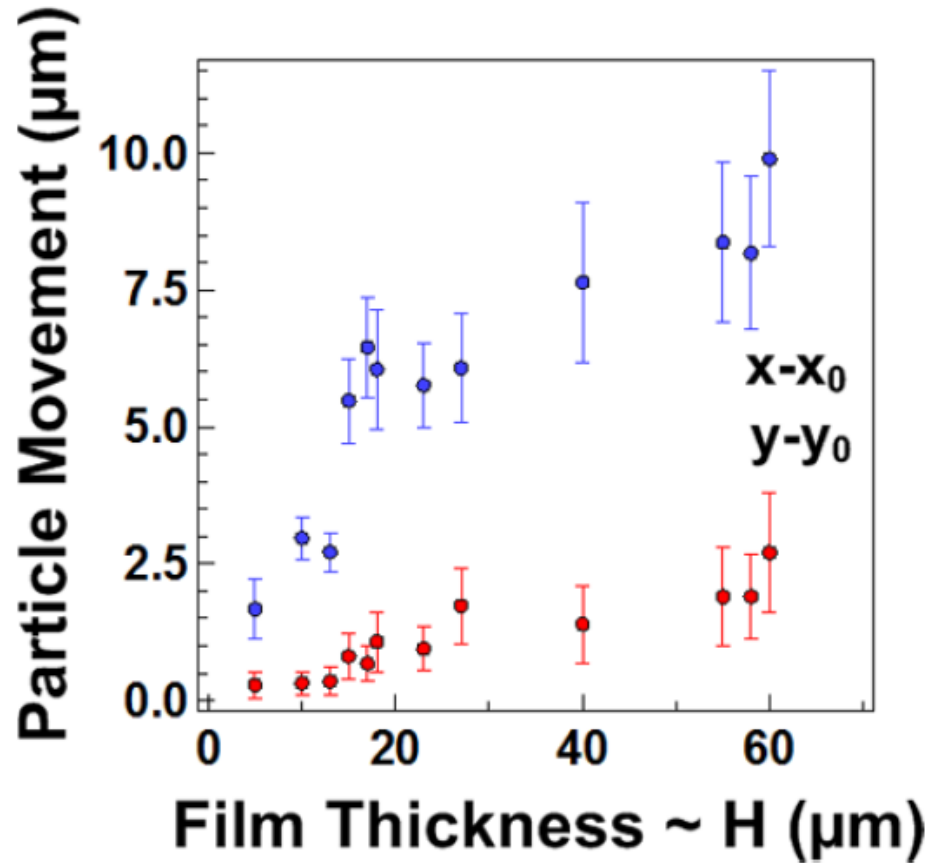
- ❑ Stress in the drying film produces compaction beyond transition region.
- ❑ Compaction is too small to measure for 200nm particles → no banding

$$dx = dx_{\max}[1 - \exp(-D/\lambda_{\text{fit}})]$$

- ❑ λ_{fit} closely matches the spacing between shear bands.

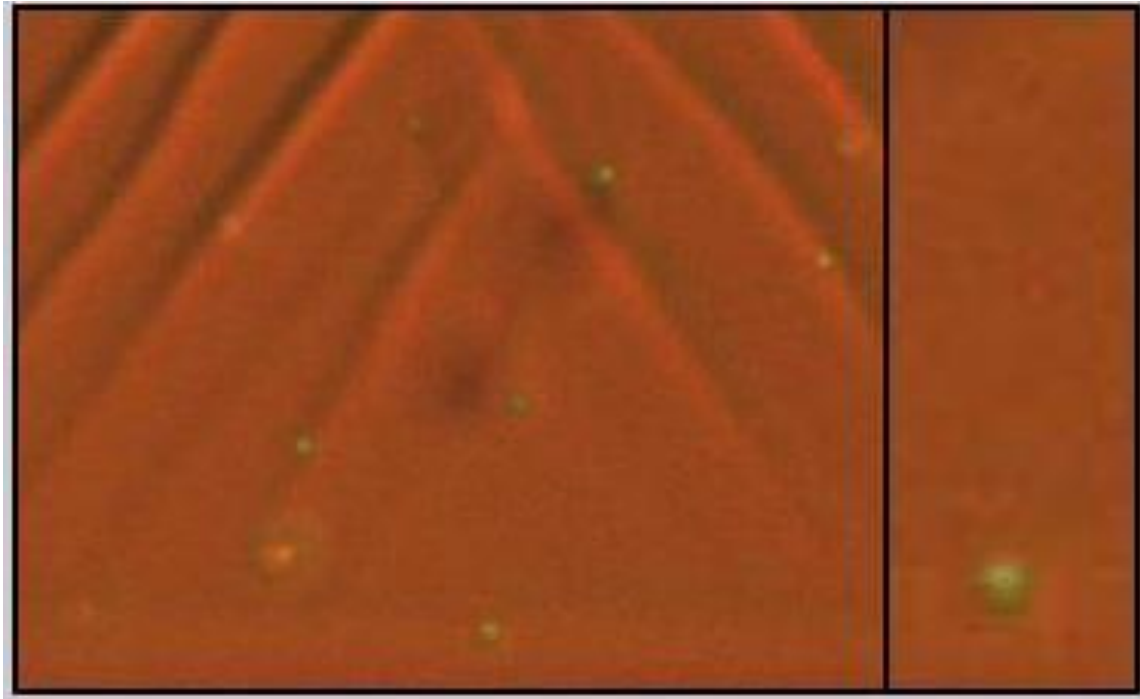
- 50nm, $H=60\mu\text{m}$
- 50nm, $H=27\mu\text{m}$
- 100nm, $H=25\mu\text{m}$
- 200nm, $H=38\mu\text{m}$

→ Suggests compaction drives shear band formation and sets lengthscale



- ☐ Total movement of particles depends on film thickness.
- ☐ Consistent movement in the y direction also measurable
- ☐ Particles to the left of a chevron move left; particles to the right move right.
- ☐ y movement due to shear, x movement compaction + shear

Directly observing compaction and shear banding



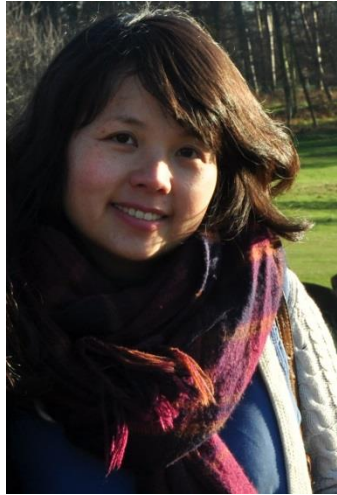
“Shear banding in drying films of colloidal nanoparticles”
B. Yang et al ACS Nano 9, 4077-4084 (2015)

Conclusions

- ❑ Diagonal lines observed in drying films are shear bands
- ❑ The spacing of bands depends on film yield stress and obeys a simple Lever Rule
- ❑ Particle tracking shows that compaction after the transition region provides the driving force for shear band formation.

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Acknowledgements



Dr Bin Yang



Dr James Sharp

Funding:

